

## Abstract

# Analysis and Development of Rotational Angle Sensor <sup>†</sup>

Yu-Wen Chen <sup>1</sup> and Cheng-Yao Lo <sup>1,2,\*</sup> 

<sup>1</sup> Institute of NanoEngineering and Microsystems, National Tsing Hua University, Hsinchu 300044, Taiwan; n0022057@hotmail.com

<sup>2</sup> Department of Power Mechanical Engineering, National Tsing Hua University, Hsinchu 300044, Taiwan

\* Correspondence: chengyao@mx.nthu.edu.tw; Tel.: +886-3-516-2404

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**Abstract:** This research focuses on the rotational angle acquisition of a flexible sensor. A numerical analysis is conducted during design to discuss the sensor's capacitance changes under rotation. A working range from  $-4^\circ$  to  $4^\circ$  is investigated and fittings are predicted. Furthermore, manufacturing processes are used to realize the electrode, mold and spacers. After that, the sensor is measured to determine its capacitance signal.

**Keywords:** rotational sensor; angle acquisition; capacitive type

## 1. Introduction

With the advancement of intelligent manufacturing, sensing technology has attracted people's attention, and especially the application of flexible sensors, which are accompanied by a variety of functions [1]. Currently, rotation and angle detection are topics that people seldom discuss. Many studies have merely focused on normal or shear force detection; even shear angle analyses and torsion detection can hardly be found. For instance, Pang et al. proposed a nanofiber sensor for rotational detection [2]. This sensor gave us an idea of what rotational sensing could be; however, this study focused on the motion itself and did not go further into angle analysis. Choi et al. also proposed a rotational sensor based on frictional torque. The ion gel level in the sensor rose when the rotational force was greater, resulting a smaller contact area [3]. In particular, the detection of a rotation force and its angle has not been frequently found in current research. In addition, attention has been paid to the performance of power while its rotation angles have not yet been studied; therefore, we take the advantage of this gap to develop a tactile sensor that analyzes the rotation angle of forces.

## 2. Materials and Methods

In this sensor, there are 8 layers from the bottom up, as illustrated in Figure 1a. In the spacers, three settings are involved: four squares in the corners, two sides featuring rectangular spacers, and another square in the middle; all are 20  $\mu\text{m}$  in height. The fourth layer is a PDMS plane with a thickness of 30  $\mu\text{m}$ , ensuring two electrodes remain 50  $\mu\text{m}$  apart. In addition, two electrodes of the same size, which are 4600  $\mu\text{m} \times 2100 \mu\text{m}$ , are intentionally shifted with 100  $\mu\text{m}$  clearance to enable angle detection. To understand the suitability of this sensor for manufacturing, numerical evaluation is used to predict the results. With the applying of rotation, a change in capacitance value is observed. Consequently, the angle measurement of the sensor design is validated using a rotational stage, as shown in Figure 1b.



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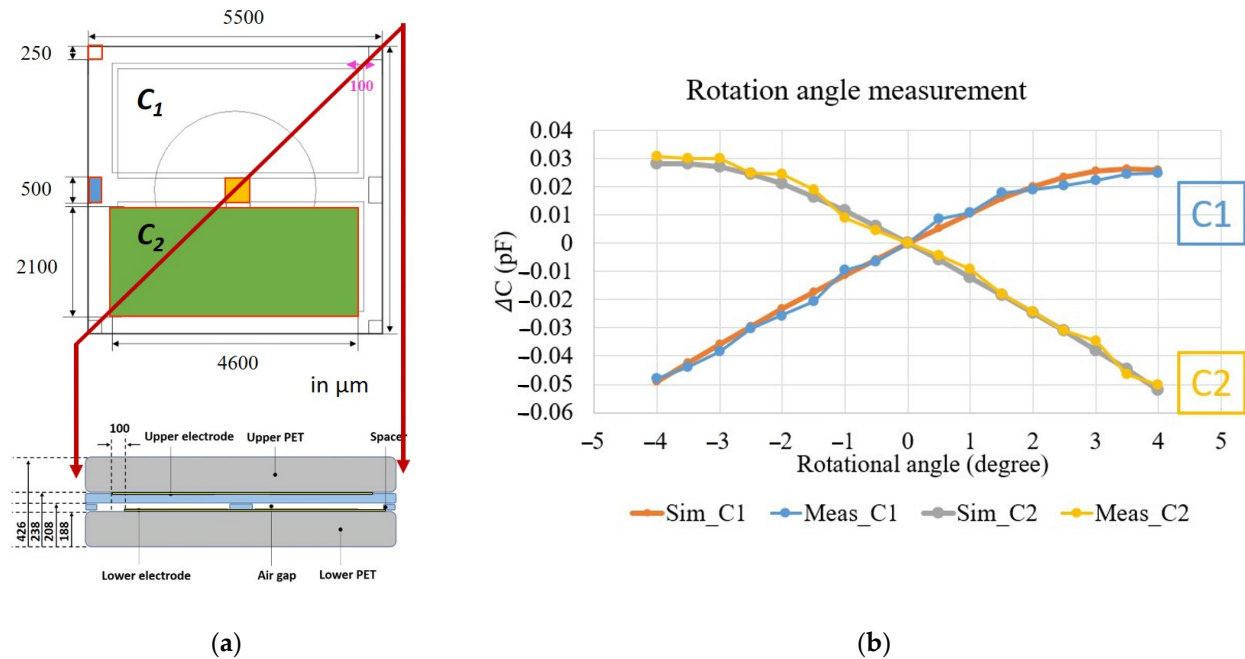
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**Figure 1.** (a) thickness and layers of the rotational angle sensor; (b) plane and cross-sectional views of the sensor.

### 3. Discussion

Our result of a capacitance response is simulated by setting rotation angles from  $-4^\circ$  to  $4^\circ$ . The capacitance variation tends to be linear from  $-2.5^\circ$  to  $4^\circ$  for  $\Delta C_1$  and  $-4^\circ$  to  $2.5^\circ$  for  $\Delta C_2$ . The upper electrode,  $\Delta C_1$ , tends to be saturated from  $2.5^\circ$  to  $4^\circ$  while the bottom electrode,  $\Delta C_2$ , develops further toward a more negative value. It was found that these measurements overlap with the simulation results, proving the feasibility of this sensor. We assume that the ideal overlapping area is correlative to capacitance change. Then, we substituted  $\Delta A_1$  and  $\Delta A_2$ 's linear fitting results, with relation to the rotational angle ( $\varphi$ ) and  $\Delta C$ , into (1); hence, (2) and (3) can be summarized. The ideal overlapping area in  $\text{m}^2$  can be analyzed using AUTOCAD and linear fitting for  $\Delta C_1$  and  $\Delta C_2$ . It can be seen that the ideal overlapping area's changes are mostly the same with fitting; however, for an angle greater than  $2.5^\circ$  ( $\Delta C_1$ ) or smaller than  $-2.5^\circ$  ( $\Delta C_2$ ), the variation does not obey the fitting results, which means that errors occur for  $\Delta C_1$  and  $\Delta C_2$ . Therefore, when the angle is between  $2.5^\circ$  and  $-4^\circ$ ,  $\Delta C_1$  is used to obtain the angle; on the other hand, when the angle is between  $-2.5^\circ$  and  $4^\circ$ ,  $\Delta C_2$  is used.

#### The Formatting of Mathematical Components

$$\Delta C = \frac{\epsilon_0}{\frac{\epsilon_{air}}{g_{air}} + \frac{\epsilon_{PDMS}}{g_{PDMS}}} \times \Delta A \quad (1)$$

$$\Delta A_1(\text{m}^2) \text{ _Fitting } (\varphi) = 0.0565\varphi(\text{degree}) + 0.0006; R^2 = 0.997; \varphi(\text{degree}) \approx \Delta C_1(\text{pF}) \times 119.904(\text{degree/pF}) \quad (2)$$

$$\Delta A_2(\text{m}^2) \text{ _Fitting } (\varphi) = -0.0565\varphi(\text{degree}) + 0.0006; R^2 = 0.997; \varphi(\text{degree}) \approx -\Delta C_2(\text{pF}) \times 119.904(\text{degree/pF}) \quad (3)$$

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